



THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of)

James E. Moon et al.)

Patent Application No.: 10/003,851)

Filed: November 2, 2001)

For: METHOD FOR FABRICATING MEMS)
AND MICROFLUIDIC DEVICES USING)
SMILE, LATENT MASKING, AND)
DELAYED LOCOS TECHNIQUES)

Art Unit: 1763

Examiner: Allan W. Olsen

AMENDMENT AND RESPONSE

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Sir:

The following amendments and remarks are submitted in response to the Office Action of
April 30, 2004 in the above-identified patent application.